

## WEST Search History

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DATE: Tuesday, April 13, 2004

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		<i>DB=PGPB,USPT,EPAB,JPAB,DWPI,TDBD; PLUR=YES; OP=OR</i>	
<input type="checkbox"/>	L1	((post etch) and (metal lines) and wafer and stripping and ((organic solvent\$) or alcohol\$) and water and ((inert gas) or nitrogen) and immersing and removing and maintaining)	1

END OF SEARCH HISTORY

Day : Tuesday  
Date: 4/13/2004  
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 **PALM INTRANET**

## Inventor Name Search Result

Your Search was:

Last Name = NI

First Name = CHIH-JUNG

Application#	Patent#	Status	Date Filed	Title	Inventor Name 4
<a href="#">10335294</a>	Not Issued	051	12/31/2002	METHOD FOR REMOVING SI-NEEDLES OF WAFER	NI, CHIH-JUNG
<a href="#">10250038</a>	Not Issued	030	05/30/2003	FLASH MEMORY CELL AND FABRICATION THEREOF	NI, CHIH-JUNG
<a href="#">10063975</a>	Not Issued	030	05/30/2002	METHOD OF SPIKING MIXED ACID LIQUID IN REACTOR	NI, CHIH-JUNG
<a href="#">10057906</a>	Not Issued	071	01/29/2002	CLEAN EQUIPMENT FOR REMOVING POLYMER RESIDUES ON SIDEWALLS OF METAL LINES AND METHOD THEREOF	NI, CHIH-JUNG

Inventor Search Completed: No Records to Display.

**Search Another:**  
**Inventor**

<b>Last Name</b>	<b>First Name</b>
<input type="text" value="ni"/>	<input type="text" value="chih-jung"/>
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